740756-2438 6-26-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **New Patent** Application of   )

Shunpei YAMAZAKI et al   ) Attn: Applications

Japanese Priority No.:   2001-049468   )   Branch

Japanese Priority Date: February 23, 2001   )

For: METHOD OF MANUFACTURING A   ) Date: February 20, 2002

SEMICONDUCTOR DEVICE   )
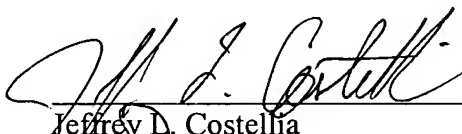
INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231
Sir:

      In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

      Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

      Respectfully submitted,

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JLC/sas

Substitute for form 1449A/PTO	**INFORMATION DISCLOSURE STATEMENT BY APPLICANT** *(use as many sheets as necessary)*			*Complete if Known*	
				Application Number	Not Yet Assigned
				Filing Date	February 20, 2002
				First Named Inventor	Shunpei YAMAZAKI et al
				Group Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
Sheet	1	of	1	Attorney Docket Number	740756-2438

U.S. PATENT DOCUMENTS

Examiner Initials*	Cited No.	U.S. Patent Document Number	Kind Code[2] (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		6,281,057		Aya et al	08/28/2001	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cited No.	Foreign Patent Document Office[3]	Number[4]	Kind Code[5] (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T[6]
		JP	11-074536 A		H. Abe et al	03/16/1999		W/Abstract

Examiner Signature		Date Considered	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

[1] Unique citation designation number. [2] See attached Kinds of U.S. Patent Documents. [3] Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). [4] For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. [5] Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. [6] Applicant is to place a check mark here if English language Translation is attached.

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